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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

June application of:

Bo Gu, et al.

Group Art Unit: 1725

Examiner:

Serial No.: 10/787,517

Filed: February 26, 2004

For: LASER SYSTEM AND METHOD FOR MATERIAL PROCESSING WITH
ULTRA FAST LASERS

Attorney Docket No.: GSIL 0191 PUSP

STATUS INQUIRY

Commissioner for Patents
U.S. Patent & Trademark Office
P.O. Box 1450
Alexandria, VA 22313-1450

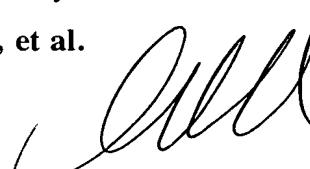
Sir:

Please inform us of the status of the above-identified patent application and as to when we may expect an Office Action from the U.S. Patent and Trademark Office.

Respectfully submitted,

Bo Gu, et al.

By:



David R. Syrowik
Reg. No. 27,956
Attorney/Agent for Applicant

Date: February 10, 2005

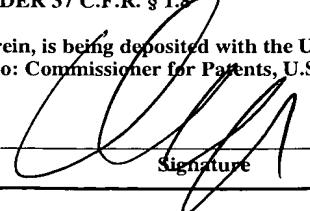
BROOKS KUSHMAN P.C.
1000 Town Center, 22nd Floor
Southfield, MI 48075-1238
Phone: (248) 358-4400
Fax: (248) 358-3351

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